

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS: JENNIFER WANG
 HUI-MIN SHENG
 MIKE BARSKY

SERIAL NO. 10/782,723 **EXAMINER:** CHEN, KIN CHAN

FILED: FEBRUARY 18, 2004 **ART UNIT:** 1765

TITLE: **DRY ETCHING PROCESS FOR COMPOUND SEMICONDUCTOR**

COMMISSIONER FOR PATENTS
P.O. BOX 1450
ALEXANDRIA, VA 22313-1450

RESPONSE AND AMENDMENT

Sir:

Applicants submit this Response and Amendment to the Office action of January 18, 2006. Please amend the applicant as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.